

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 14219-087US1	Application No. <b>10/532433</b>
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Heinz Florian, et al.	
		Filing Date	Group Art Unit

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
/DR/	AA	6,773,621	08/10/04	Marianne Hammer			
/DR/	AB	2002/0098333	07/25/02	Adalbert Feltz et al			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
/DR/	AL	WO02/055450	07/18/02	WIPO				
/DR/	AM	WO01/45138	06/21/01	WIPO				
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
/DR/	AQ	Barlingay C. K. et al, "Dopant Compensation Mechanism and Leakage Current in Pb(Zr <sub>0.52</sub> Ti <sub>0.48</sub> )O <sub>3</sub> Thin Films", Thin Solid Films, 1996, Elsevier, Switzerland, Bd. 272, Nr. 1, Pages 112-115
/DR/	AR	Barlingay C. K. et al, "Observation of Sol-gel Solid Phase Epitaxial Growth of Ferroelectric Pb(Nb, Zr,Ti)O <sub>3</sub> Thin Films on Sapphire", Applied Physics Letters, 1992, USA, Bd. 61, Nr. 11, Pages 1278-1280
/DR/	AS	Zou Q. et al, "Microstructural Characterization of Donor-doped Lead Zirconate Titanate Films Prepared by Sol-gel Processing", Preparation and Characterization, Elsevier Sequoia, NL, Bd. 402, Nr. 1-2, 2002, Pages 65-70

Examiner Signature /Derek Rosenau/	Date Considered 12/27/2007
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
/DR/	AT	Remiens D. et al, "Piezoelectric Properties of Sputtered PZT Films: Influence of Structure, Micro Structure, Film Thickness (Zr, Ti) Ratio and Nb Substitution", Materials Science in Semiconductor Processing, Elsevier Science Publishers B. V., Barking UK, Bd. 5, Nr. 2-3, 2002, Pages 123-127

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